IV-characterization of silicon sensors irradiated up to 2E16neq/cm²

Thursday 3 December 2015 09:00 (20 minutes)

Miniature silicon strip detectors (1x1cm) with different thicknesses (50, 100, 150 and 300 µm) from Hamamatsu K.K. and Micron Semiconductor Ltd. were irradiated at Birmingham and Ljubljana with doses up to 2E16 neq/cm². IV measurements were performed at different temperatures for the determination of the effective energy Eeff and the current related damage rate α directly after irradiation and after room temperature annealing (10 days and 30 days). The results of these measurements performed at Liverpool will be presented in this talk.

A second set of sensors of the same type and irradiation campaign have been measured in Freiburg with a different set-up. These results will be shown by Moritz Wiehe at this workshop.

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Session Classification: Sensors with intrinsic gain